

U.S. Serial No.: 10/569,838
Docket No.: F06-436-US
FUJIT.081

REMARKS

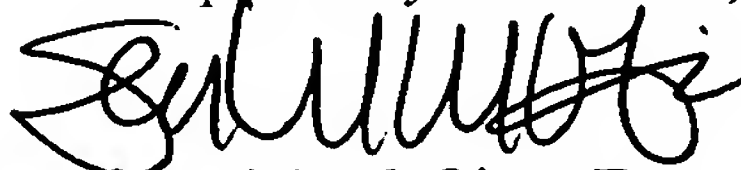
In response to the Examiner's Restriction Requirement, Applicant hereby elects the invention of Group I (e.g., drawn to a method of producing carbon nanowalls with plasma, classified in class 427, subclass 577, as defined by claims 38-45 and 54-64), without traverse. Applicant reserves the opportunity to file a Divisional Application for the non-elected invention later.

Further, Applicant respectfully requests the Examiner's acknowledgment of the claim to priority and priority document.

Early, favorable prosecution on the merits is respectfully requested.

Should the Examiner find the application to be other than in condition for allowance, the Examiner is requested to contact the undersigned at the local telephone number listed below to discuss any other changes deemed necessary in a telephonic or personal interview. A conditional petition is made for any extension of time which may become necessary. The Commissioner is authorized to charge any fees for such extension and to credit any overpayment in fees to Attorney's Deposit Account No. 50-0481.

Respectfully Submitted,



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Registration No. 34,386

Date: _____

8/12/09

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